

Notice of References Cited	Application/Control No. 09/370,508	Applicant(s)/Patent Under Reexamination SHARMA ET AL.	
	Examiner DuyVu n Deo	Art Unit 1765	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
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	B	US-6,030,541-	02-2000	Adkisson et al.	438	717
	C	US-6,245,682-	06-2001	Fu et al.	438	696
	D	US-5,620,913-	04-1997	Lee	438	264
	E	US-5,605,601-	02-1997	Kawasaki	156	643.1
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, Vol. 1, pg 539-542					
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.